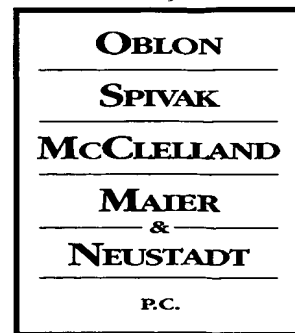




Docket No.: 245583US0S DIV

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313



ATTORNEYS AT LAW

RE: Application Serial No.: 10/716,142
Applicants: Satoshi MATSUDA, et al.
Filing Date: November 19, 2003
For: SEMICONDUCTOR DEVICE HAVING SILICIDE
FILM AND MANUFACTURING METHOD
THEREOF
Group Art Unit: 2812
Examiner: GURLEY, L.A.

SIR:

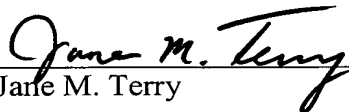
Attached hereto for filing are the following papers:

Response to Restriction Requirement

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon


Jane M. Terry
Registration No. 53,682

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)

DOCKET NO: 245583US0S DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

SATOSHI MATSUDA, ET AL.

: EXAMINER: GURLEY, L. A.

SERIAL NO: 10/716,142 :

FILED: NOVEMBER 19, 2003

: GROUP ART UNIT: 2812

FOR: SEMICONDUCTOR DEVICE :
HAVING SILICIDE FILM AND
MANUFACTURING METHOD THEREOF

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement mailed May 12, 2004, Applicants elect, with traverse, **Group I (Claims 14-20)** for further prosecution in the above-identified application.